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PATENTS MD

## <u>IN THE UNITED STATES PATENT AND TRADEMARK OFFICE</u>

Applicant(s): Douglas A. Buchanan, et al.

Examiner: Jeff B. Vockrodt

Serial No: 09/553,997

Art Unit: 2822

Filed: April 20, 2000

Docket: YOR920000036US1 (13322)

For: PRECURSOR SOURCE MIXTURES,

Dated: March 27, 2002

METHODS OF FILM DEPOSITION, AND FABRICATION OF STRUCTURES

Assistant Commissioner for Patents United States Patent and Trademark Office Washington, D.C. 20231

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RESPONSE UNDER 37 C.F.R. §§1.111 AND 1.143

MAR 27 2002

**TECHNOLOGY CENTER 2800** 

Sir: In response to the Office Action dated February 27, 2002, applicants provisionally elect precursor compounds wherein R1 is a hydride group.

## **REMARKS**

Favorable consideration and allowance of the claims of the present application are respectfully requested.

## CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that this paper is being facsimile transmitted to the Patent and

Trademark Office on the date shown below.

Dated: March 27, 2002